



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): Jeong-Hyun Oh; et al.

SERIAL NO.: UNASSIGNED

EXAMINER: UNASSIGNED

DATE FILED: December 28, 2000

ART UNIT: UNASSIGNED

FOR: METHOD FOR FABRICATING HIGH-PURITY SILICA GLASS
USING SOL-GEL PROCESSING

CERTIFICATE OF MAILING UNDER 37 CFR §1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, DC 20231 on December 28, 2000.

Barbara Strathearn
(Name of depositor)

Barbara Strathearn 12/28/00
(Signature and Date)

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

INFORMATION DISCLOSURE STATEMENT

In accordance with Applicant's and Applicant's representatives' Duty of Disclosure under 37 CFR § 1.56, and pursuant to 37 CFR §1.97 and MPEP 717.05(b), Applicant(s) submit herewith documentary information for consideration by the Examiner. Information herein cited is only set forth in fulfillment of Applicant's duty of candor in disclosing all information brought to his attention, and is not an admission that it can be used adversely. The publications forwarded herewith are listed on the enclosed Form PTO-1449. Applicant(s) request that the Examiner, upon reviewing the enclosed materials, initial the enclosed form and return a copy thereof in accordance with the instructions on the form.

Enclosed please find copy of Reference AA listed on the attached Form PTO-1449.

The enclosed is being provided for the convenience in the examination of the present Application, in the event that these materials were not forwarded by the International Searching Authority. According to MPEP §609, Minimum Requirements for an Information Disclosure Statement, Content A(3), the concise explanation of relevance of this item may be indication "X", "Y", or "A" listed on the enclosed search report.

No fee is believed due for the filing of this statement inasmuch as it is being filed before the mailing of the first official action on the merits. However, should the Patent and Trademark Office determine otherwise, authorization is hereby given to charge Deposit Account No. 11-1153 for this filing.

Respectfully submitted,



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